

S/N 09/909,532



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kie Y. Ahn et al.

Examiner: Maria Guerrero

Serial No.: 09/909,532

Group Art Unit: 2822

Filed: July 20, 2001

Docket No.: 303.377US3

Title: POROUS SILICON OXYCARBIDE INTEGRATED CIRCUIT INSULATOR

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A.W.*

AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111

Commissioner for Patents
P.O.Box 1450
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This paper is in response to the Office Action mailed on March 18, 2003. Please amend the above-identified patent application as follows.

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